

10/583,619

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

P1510US

Application Number

10/583,619

Applicant(s)

Shoji Tanaka et al.

Filing Date

Concurrently herewith

Group Art Unit

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/JC/		9-73559 03/	1997	Japan				✓
/JC/		11-143352 05/	1999	Japan				✓
/JC/		2000-194835 07/	2000	Japan				✓
/JC/		2003-44837 02/	2003	Japan				✓
/JC/		2003-216931 07/	2003	Japan				✓

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

/JC/		"Real Time Makeup Simulator" - Takao Furukawa et al., Dai 19 Kai Sensing Forum Shiryo, September 17, 2002, 19th, pgs. 53-58.

EXAMINER

/Jose Couso/

DATE CONSIDERED

03/04/2009

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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				Applicant(s) Shoji Tanaka et al.				
				Filing Date October 29, 2004		Group Art Unit --		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
/JC/		6,633,289	10-2003	Lotens et al.				
U.S. PATENT APPLICATION PUBLICATIONS								
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FOREIGN PATENT DOCUMENTS								
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							YES	NO
/JC/		WO 99/23609 05/	1999	WIPO			✓	
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/Jose Couso/				03/04/2009				
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